The 9th International SiGe, Ge, & Related Compounds: Materials, Processing, and Devices Symposium is the G03 Symposium in PRiME 2020. This meeting will provide a forum for reviewing and discussing materials and device related aspects of SiGe, Ge, and Related Compounds. There are 10 areas of interest:

1. Heterojunction Bipolar Transistors
Device physics, process technology, modeling, reliability, circuit applications (analog, digital, and RF to mm-wave).

2. FET Technology
Advanced CMOS, Compound Semiconductor Devices (III-V, Group IV), 2-D Materials FET, TFET, FDSOI, FinFETs, Nanowire FETs, Negative-Capacitance FET, Oxide TFTs, Ferroelectric FETs, and transistors with high bandgap materials (SiC, GaN, and Ga_{2}O_{3}).

3. Optoelectronics
Detectors, Waveguides, Quantum cascade structures, Photovoltaic cells, Photoluminescence, Electroluminescence, Integration with CMOS electronics, Ge buffers for III-V Optoelectronics on Si, monolithic optoelectronic integrated circuits (OEICs).

4. Epitaxy
Pre-epi surface preparation of Si, SiGe and Ge; Growth of Group IV epitaxial layers: graphene, Si, Ge, SiC, SiGe, SiGe:C, GeSn, SiGeSn. Epitaxial growth of other materials on Si or Ge such as III-V’s; Novel growth techniques and precursors; Selective growth; Novel in-situ doping approaches; Quantum wire/dot growth.

5. Emerging Applications
Nano-structured devices, quantum computing, THz devices, electro-mechanical properties of SiGe layers, MEMs, TFTs, amorphous SiGe layer applications.

6. Process and Integration
All aspects of integration like substrate engineering, monolithic and hetero-integration of SiGe/Ge devices and systems; yield, reliability and related processing including diffusion and suppression, Si/Ge intermixing, Oxidation and Nitridation, Cleaning & etching of SiGe, Ge, and SiGeC.

7. Strain Engineering
Stress engineering for GAA (Gate-All-Around) transistors. Performance and reliability of PMOS and NMOS transistors with SiGe and striped Si/SiGe channels. Stress engineering for 3D stacking technology. Efficiency of stress engineering for ultra-short channels approaching L = 10 nm. Ge quantum wells.

8. Surfaces and Interfaces
Surface Passivation, High K interface, Metal Contact, Interfacial electrical properties and its characterization. Electro-mechanical properties of SiGe layers, MEMs, TFTs.

9. Related Compounds
Material growth, processing, and characterization of related compounds (such as GaN, SiC, h-BN, etc.), devices with emerging applications (such as Micro LED/Mini LED, GaN on Si power electronics…) and device reliability.

10. Metrology & Characterization
Advancements in the nanoscale characterization of Group IV and III/V alloys in terms of their bulk (composition, strain, crystallinity, doping, dimensions, morphology, band structure, mobility) as well as surface/interface properties.

Evening Panel Session
A Panel of experts will discuss issues related to a topic in SiGe, Ge, or Related Compounds

Poster & Poster/Student Presentation Award Session

For the latest symposium details please see the symposium website at: www.sigesymposium.com.
Website maintained by Gianlorenzo Masini (masini@cisco.com)
Abstract Submission
All authors must submit an ECS abstract to the ECS PRIME2020 Website below, which is open for abstract submission till **May 29, 2020**. [https://ecs.confex.com/ecs/prime2020/cfp.cgi](https://ecs.confex.com/ecs/prime2020/cfp.cgi)
Please select symposium **G03: SiGe, Ge, & Related Compounds: Materials, Processing, and Devices 9**.

**Deadline Abstract Submission**
**May 29, 2020**
[ecs.confex.com/ecs/prime2020/cfp.cgi](https://ecs.confex.com/ecs/prime2020/cfp.cgi)

Proceedings Manuscript Submission
The Symposium Proceedings will be published in ECS Transactions (ECST), available at the time of the Symposia, serving as the digest of technical papers. All regular and invited paper authors are required to submit a full-length manuscript to the Electrochemical Society website to be included in the Proceedings. Please contact the Symposium Organizers for special cases. Detailed instructions and templates for the preparation of the Manuscript are found at the ECS Website, which will be open for manuscript submission on **July 17, 2020**. Please note that the Proceedings Manuscript must be submitted to the Electrochemical Society website by **Aug. 7, 2020**.

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